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Prof. Rachel B. Getman  
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**Your Specific Deadline Date**

I am preparing an *ACS LiveSlides* entitled:

Machine Learning Accelerates the Discovery of Design Rules and Exceptions in Stable Metal-Oxo Intermediate Formation

to appear with

Machine Learning Accelerates the Discovery of Design Rules and Exceptions in Stable Metal-Oxo Intermediate Formation

Title of ACS Publication and DOI

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Submit completed and signed form with your signed *ACS LiveSlides* Video Release.

7/25/16